

Notice of References Cited

Application No.
09/414,526

Applicant(s)
Kim et al.

Examiner
Michael Cleveland

Group Art Unit
1762

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U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A	5,851,849	12/1998	Comizzoli et al.	438	38
B					
C					
D					
E					
F					
G					
H					
I					
J					
K					
L					
M					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N						
O						
P						
Q						
R						
S						
T						

NON-PATENT DOCUMENTS

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
X U	Y. Kim et al., "Substrate dependence on the optical properties of Al ₂ O ₃ films grown by atomic layer deposition", Appl. Phys. Lett., 71(25), pp. 3604-3606	12/1997
V		
W		
X		